

**CONTENTS**

Preface	xiii
1. Microelectronics processing	1
2. Theory of transport processes in semiconductor crystal growth from the melt	35
3. Liquid-phase epitaxy and phase diagrams of compound semiconductors	105
4. Physical vapor deposition reactors	171
5. Chemical vapor deposition	199
6. Diffusion and oxidation of silicon	265
7. Resists in microlithography	325
8. Plasma-enhanced etching and deposition	377
9. Interconnection and packaging of high-performance integrated circuits	441
10. Semiconductor processing problems solved by wet (solution) chemistry	505

**INDEXES**

Author index	523
Affiliation index	523
Subject index	523